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SERIAL NO.: To Be Assigned
FILED: Herewith
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Amendments to the Specification:

On page 1, immediately after the title, please insert:

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PRIOR APPLICATION DATA

The present application is a National Phase Application of PCT International Application PCT/PT2003/000004, entitled "Maskless Optical Interferometric Lithography" filed on March 25, 2003, which is incorporated herein by reference in its entirety.--